



## Characteristics of AlGaAs/GaAs heterostructure RT-SCR model

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### ABSTRACT

Electrical properties of a resonant-tunneling-semiconductor-controlled rectifier (RT-SCR) model have been presented. The current, temperature, gain, doping concentration, and layer size versus voltage relationships have been numerically obtained. The RT-SCR device requires smaller turn-on voltage than a comparable traditional device for the same gate current. This indicates that, in comparison with the traditional thyristor, a smaller control current may be used to turn on the device at a particular voltage. Characteristics of the device are affected by p1, n1, and p2 regions. It is shown that higher doping concentrations cause lower turn-on voltages and an increase in the region width results in higher turn-on voltages for p1 and p2 regions. Changing the doping concentration and width in n1 region affects the characteristics of the structure differently from that of the p1 and p2 regions.

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### 1. Introduction

The pnpn thyristor structure has been around and used as a semiconductor switch to handle large amounts of currents. Traditionally, the pnpn thyristor structure is modeled with two transistors: a pnp transistor and an npn transistor—the base of each transistor is connected to the collector of the other transistor.

For a resonant-tunneling-semiconductor-controlled rectifier (RT-SCR) device, the npn transistor is replaced with a resonant-tunneling transistor (RTT) with an anticipation of reducing the turn-on current. The simulation results indicate that the RT-SCR is turned on at a lower voltage than the turn-on voltage of the traditional SCR for the same gate current [1]. Because tunneling is inherently a very fast phenomenon, the structure has a high potential to be used as a fast turn-on switch. Although resonant tunneling has some major problems, it has many advantages for high-speed devices [2,3]. The RTD is considered among the fastest devices ever made [4]. Like RTD, RTTs have many advantages such as faster switching time for high-speed operation devices; the RT-SCR is expected to have a fast switching response [1].

In this work, the tunneling characteristics of a RT-SCR device are outlined, and electrical properties of the RT-SCR model are presented.

### 2. Resonant-tunneling-semiconductor-controlled rectifier

A pnpnpn AlGaAs/GaAs heterostructure has been used in the simulation of the RT-SCR device. The circuit given in Fig. 1 is used to model the RT-SCR structure. It is the modified two-transistor model, which has  $T_1$  as a traditional pnp bipolar transistor and  $T_2$  as an RTT [5].

#### 2.1. The current–voltage equations

The anode current of RT-SCR can be expressed as follows:

$$I_{A_{RT}} = \frac{\alpha_{2RTT} I_g + I_{CORTT} + I_{CO1}}{1 - (\alpha_1 + \alpha_{2RTT})} \quad (1)$$

The common-base current gain  $\alpha_{2RTT}$  for the resonant-tunneling structure will be as follows:

$$\alpha_{2RTT} = \frac{I_{CRTT}}{I_{ERTT}} \quad (2)$$

The voltage distribution in the model for the RT-SCR is shown in Fig. 1. The anode–cathode voltage is as follows:

$$V_{AK} = V_{BE1} + V_{BC} + V_{BE_{RTT}} \quad (3)$$

#### 2.2. The physical structure

For the model, a physical RTT structure reported by Wu et al. [6] is adopted. The structure for the RT-SCR is shown by splitting the structure and adding necessary regions as shown in Fig. 2.

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In the model, the tunneling takes place between the gate and the cathode.

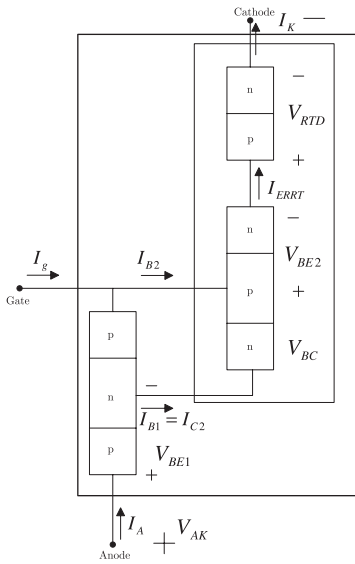
The physical properties of p1, p2, n1, and n2 regions are given in Table 1.

**3. Simulation results**

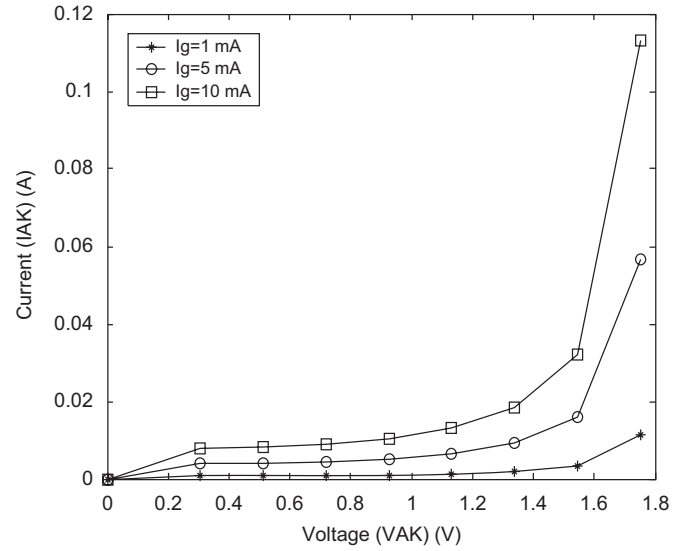
MATLAB has been used to obtain electrical properties of the device. The results are presented in a graphical form in Figs. 3–13.

**Table 1**  
Physical properties of the four layers in the RT-SCR structure

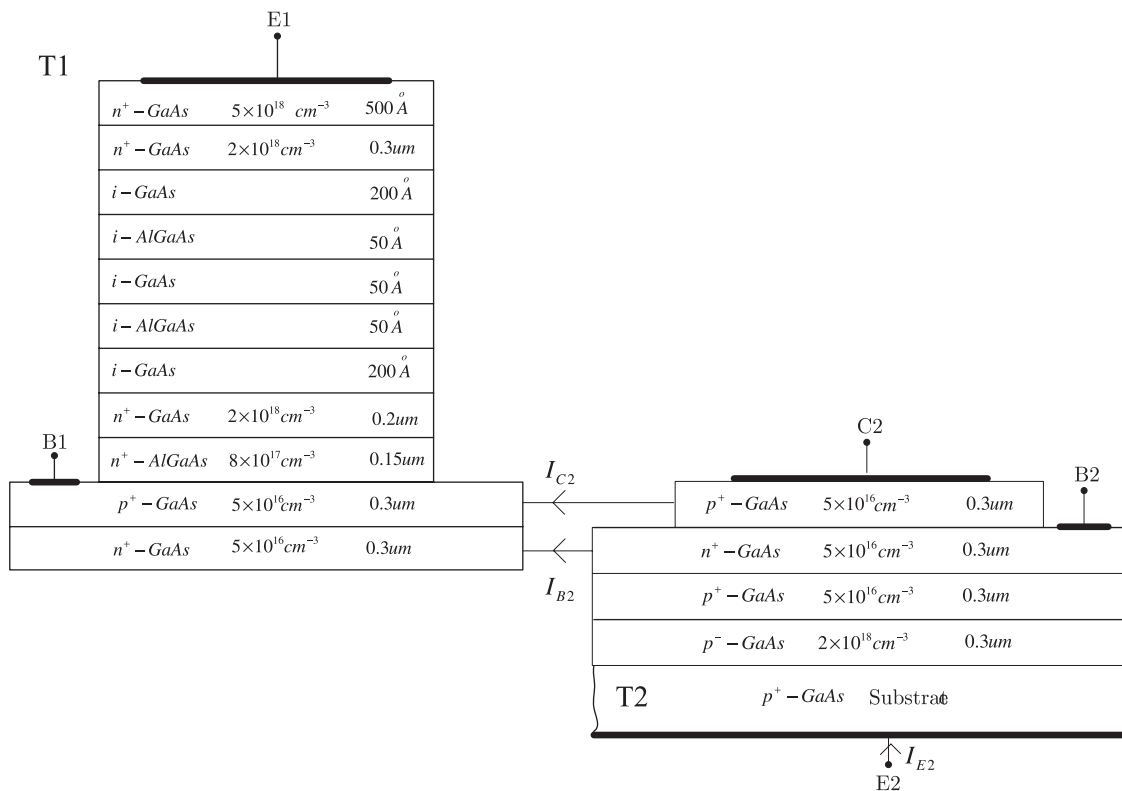
Region	Material	Doping ( $\text{cm}^{-3}$ )	Thickness ( $\mu\text{m}$ )
p1	GaAs	$5 \times 10^{16}$	0.3
n1	GaAs	$5 \times 10^{16}$	0.3
p2	GaAs	$5 \times 10^{16}$	0.3
n2	AlGaAs	$8 \times 10^{17}$	0.15



**Fig. 1.** Currents and voltage distributions in a two-transistor model for the RT-SCR.



**Fig. 3.** Current-voltage characteristic of RT-SCR for different gate currents at 300 K.



**Fig. 2.** Cross-sectional drawing of the two-transistor RT-SCR model.

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